The effect of micron-sized particles on a low-pressure capacitively coupled rf discharge is studied both experimentally and using numerical simulations. In the laboratory experiments, microparticle clouds occupying a considerable fraction of the discharge volume are supported against gravity with the help of the thermophoretic force. The spatiotemporally resolved optical emission measurements are performed with different arrangements of microparticles. The numerical simulations are carried out on the basis of a one-dimensional hybrid (fluid-kinetic) discharge model describing the interaction between plasma and microparticles in a self-consistent way. The study is focused on the role of microparticle arrangement in interpreting the spatiotemporal emission measurements. We show that it is not possible to reproduce simultaneously the observed microparticle arrangement and emission pattern in the framework of the considered one-dimensional model. This disagreement can be attributed to the two-dimensional effects (e.g., radial diffusion of the plasma components) or to the lack of the proper description of the sharp void boundary in the frame of fluid approach.

DOI: 10.1103/PhysRevE.96.033203

I. INTRODUCTION

Low-pressure capacitively coupled rf discharges containing micro- or nanometer-sized particles have attracted a lot of attention in the past few decades. This interest was mainly driven by technological applications of such systems, e.g., for nanoparticle growth in plasmas [1–6]. It was shown long ago that the presence of nanoparticles leads to dramatic changes in plasma properties [7–9].

Cold low-pressure plasmas with micron-sized particles have also found their application in basic science. They are used to create so-called complex plasmas [10,11], where the subsystem of strongly coupled microparticles is easily accessible for observation at the atomistic level. Various generic phenomena of condensed matter physics can be studied using complex plasmas. To achieve large three-dimensional microparticle clouds, complex plasma experiments are often performed under microgravity conditions [12,13], where the microparticles occupy a significant part of the discharge volume. In this case, their interaction with the background plasma becomes very important. Development of future microgravity plasma experiments would require fighting back the present drawbacks, namely strong inhomogeneity of the microparticle clouds (due to the microparticle-free areas, so-called voids [12]) and low-frequency instabilities of the microparticle component (e.g., heartbeat instability [14,15]). This challenging goal can hardly be achieved without fundamental understanding of the interaction between the microparticle clouds and plasmas.

In recent years, this interaction has been studied both experimentally and using numerical simulations in several works [16–19]. Experimentally, the deepest insight into the plasma kinetics can be achieved by rf-period-resolved emission measurements. Being noninvasive, this method is very well suited for the investigations of the rf discharges with microparticles. Particle-in-cell (PIC) simulations are the most common technique that also allows to access plasma kinetics. Both rf-period-resolved measurements and PIC simulations were combined in Refs. [18,19] for the conditions of complex plasmas.

In Ref. [19], large microparticle clouds occupying the most part of the discharge volume were considered. It has been shown that the increase in the microparticle number density causes the transition in the electron heating mode. While the electrons in the microparticle-free discharge are primarily heated in the sheath regions, a nearly uniform distribution of the electron heating rate across the discharge is observed in the presence of dense microparticle clouds. This effect, which was also reported for electronegative plasmas [20–22], was attributed to the reduction of plasma conductivity due to the depletion of electrons within a microparticle cloud. The numerical simulations of Ref. [19] confirmed this mechanism for the complex plasma conditions and showed satisfactory agreement with the rf-period-resolved emission measurements.

On the other hand, the effect of microparticle arrangement on the plasma properties and observed emission pattern was not discussed in Ref. [19]. In fact, the simulations of Ref. [19] were performed for a prescribed fixed distribution of the microparticle number density. The presence of the void in the center of the discharge was not taken into account, whereas (as already mentioned above) lack of the fundamental understanding of the void constitutes a major obstacle in the improvement of microgravity plasma experiments.

In the present work, we provide some initial insights into the role of the details of the microparticle arrangement in the physics of the discharge containing a large amount of microparticles. In particular, we report on the results of experiments similar to those performed in Ref. [19]: measured space- and time-resolved emission patterns are compared with the results of numerical simulations. The simulations are performed on the basis of a one-dimensional hybrid (fluid-kinetic) model, in which the interaction of plasma with microparticles is taken into account self-consistently. This allows us to predict the microparticle cloud configuration. For
comparison, we also demonstrate the results of simulations with the fixed microparticle arrangement. Finally, the findings of our study are used to discuss the physical mechanisms underlying the formation and existence of the void usually observed in the center of the discharge.

The paper is structured as follows. In Sec. II we describe the experimental setup used in our work and the details of the rf-period-resolved emission measurements. The model used for numerical simulations is presented in Sec. III. Our main findings are summarized in Sec. IV. Discussion of the results is given in Sec. V and the conclusions are drawn in Sec. VI.

II. EXPERIMENT

A. Plasma reactor

A sketch of the experimental setup is presented in Fig. 1(a). The experiments were conducted in the PK-3 Plus chamber [12], which is a compact parallel-plate plasma reactor (the interelectrode gap is 3 cm, the electrode diameter is 6 cm). The plasma was produced by means of a capacitively-coupled rf discharge. Two electrodes were driven in push-pull mode by a sinusoidal signal with the frequency of 13.56 MHz and amplitude of about 100 V peak-to-peak. Argon fed to the chamber with 0.2 sccm gas flow was used as working gas. Pressure was controlled in the range of 20–40 Pa.

B. Microparticles

Monodisperse plastic microspheres of 1.95 μm diameter were levitated in the plasma. Under ground laboratory conditions, the microparticles concentrate themselves in the vicinity of the lower electrode. To obtain large volumetric microparticle clouds, we compensated the gravitational force by means of thermophoresis [23]. To achieve this, we controlled the temperature difference between the bottom and top flanges [24] keeping the bottom flange about 17 K hotter than the top one.

The microparticle cloud in the plasma was visualized by illuminating it with a sheet of a green (wavelength 532 nm) laser entering the chamber in its middle. Scattered laser light (filtered out by a respective interference filter) was detected by a complementary metal-oxide-semiconductor (CMOS) videocamera with the resolution of 30 μm/pix.

Typical appearance of a microparticle cloud in our experiments is shown in Fig. 1(b). As under microgravity conditions [12], the cloud has a characteristic void in its center. Dashed and dotted lines show the edges of the cloud and the axial void extension, respectively. Below we will refer to these two features for the explanation and discussion of the experimental results.

C. Emission measurements

rf-Period-resolved evolution of the plasma emission was observed by an intensified charge coupled device (ICCD) camera. Following previous studies [18,19], the emission pattern was analyzed for the argon lines 750.4 nm and 751.5 nm. These lines correspond to the transitions 2p1 → 1s2 and 2p5 → 1s4 (in Paschen notation) with lifetimes 22.5 ns and 24.9 ns, respectively [25]. To select these lines, a filter with 750 nm central wavelength and 10 nm width was placed in front of the camera lens. The camera was synchronized with the rf signal through the frequency divider which sent a synchronization pulse after every 512 rf cycles. The gate width of the ICCD camera was set to 10 ns. The signal was accumulated over the total exposure time of 1 s. The ICCD gate was moved over almost three rf periods with a step of 2 ns. A pixel of ICCD image corresponded to the length of 75 μm.

The images delivered by the ICCD camera were quite uniform in the horizontal direction. A central region of 7.5 mm width was used for analysis. Horizontally averaged vertical intensity distributions were used to build spatiotemporal emission profiles.

Since the plasma is extended along the line-of-sight of the ICCD camera, the observed emission pattern is affected, to some extent, by the line-of-sight averaging. In order to estimate
the influence of this averaging, the depth of field of the ICCD camera was characterized. This was done by imaging the same pointlike light source placed at different distances from the camera lens. In these tests, 100-mm camera lens and 750-nm filter were used. The same optical system (camera, lens and filter) was used later in all experiments. The output of a 25-μm diameter optic fiber was used as a pointlike source. The optic fiber was connected to a tungsten-halogen lamp on its other end. First, this source was placed at a distance of ±15 mm from the initial position with a step of 1 mm using a translation stage. At every step, an image was taken. The results of this test are summarized in Fig. 2 in terms of two image parameters: the spot area and maximal pixel intensity. The measured spot area inside the void varied between 50 and 400 pixel², which corresponds to the linear spatial resolution of 7–20 pixels (0.50–1.5 mm). Since the spatial resolution in every vertical layer was much smaller than the vertical plasma size, each vertical layer contributed to the line-of-sight averaged intensity seen by the ICCD camera almost with the same weight.

For the experiments, the ICCD camera was placed at the same distance of 578 ± 2 mm from the illumination laser sheet plane. The same focusing of the camera lens as in the depth-of-field test was kept.

III. MODEL

A. Basic equations

Numerical simulations were performed using a one-dimensional model of the discharge. The plasma was assumed to consist of argon atoms, electrons, singly charged argon ions and charged microparticles. The atoms were treated as a uniform background at temperature $T_g = 300$ K. The electron component was described using the conventional particle-in-cell Monte Carlo (PIC-MCC) simulation technique [26,27]. The ion component was described by means of the fluid model based on the moment equations proposed in Ref. [28]. The microparticles were treated as a fluid within the drift-diffusion model considered previously in a number of works [29–33]. The details of the model for each component are given below.

The adopted Monte Carlo model of the electron-atom and electron-microparticle collisions was based on that of Ref. [28]. The absorption of the electrons by the microparticles was modeled as an additional collision process with the orbit-motion-limited (OML) [34] cross section. In addition, the electron scattering model was improved. Namely, the differential cross section for the electron-atom collisions was calculated using the expression known from the quantum scattering theory [35]. The corresponding phase shifts were taken from Ref. [36].

The governing equations for ions included the continuity, momentum and energy equations [28]. The continuity equation reads

$$\frac{\partial n_i}{\partial t} + \frac{\partial}{\partial x}(n_i u_i) = G_{ion} - G_{ip},$$

where $t$ is time, $x$ is the coordinate along the discharge axis, $n_i$ is the ion number density, $u_i$ is the ion mean velocity, $G_{ion}$ is the local ionization source, and $G_{ip}$ is the local sink of ions due to absorption by the microparticles. The ion momentum equation reads

$$\frac{\partial (m_i n_i u_i)}{\partial t} + \frac{\partial}{\partial x} (m_i n_i u_i^2 + p_i) = e n_i E - \omega_{eg} m_i n_i u_i - n_t p_{fg},$$

where $m_i$ is the ion mass, $p_i$ is the ion pressure, $e$ is the absolute value of the elementary charge, $E$ is the electric field, $\omega_{eg}$ is the momentum-transfer frequency for the ion-atom collisions, $n_t$ is the microparticle number density, and $p_{fg}$ is the ion drag force normalized to the ion number density. The evolution of the ion pressure was governed by the energy equation

$$\frac{\partial \Pi_i}{\partial t} + \frac{\partial}{\partial x} (m_t n_i u_i^3 + 3 p_i u_i) = 2 n_t u_i E + \omega_{eg} \delta (k T_g - \Pi_i),$$

where $\Pi_i = p_i + m_i n_i u_i^2$ and $\delta$ is a correction coefficient introduced in Ref. [28]. Note that the effect of the ion-microparticle collisions is neglected in Eq. (3) due to the large difference between the ion mass and the mass of the microparticle. The definition of the effective collision frequency $\omega_{eg}$ can be found in Ref. [28].

The local terms $G_{ion}$, $G_{ip}$ and the ion drag force were calculated using the conventional expressions presented in Ref. [34]. The collection cross section for the ion-microparticle collisions was defined using the OML theory. The effect of the ion-atom collisions on the ion absorption rate was taken into account using the model of Ref. [37]. The momentum transfer cross section for ion scattering on the microparticles was evaluated using the expression from Ref. [38]. The nonlinear screening effects were taken into account by introducing the
null
In the simulations, the initial level of the microparticle number density [plateau of the blue line in Fig. 3(a)] was varied in the range between $10^{11}$ and $5 \times 10^{11}$ m$^{-3}$. In the experiments, the microparticle number density was successively increased by additional injection of microparticles. The experimental measurements showed that the gas pressure variations do not affect qualitative evolution of the emission pattern with increasing number of microparticles. For this reason, we focus below on the results obtained at the gas pressure of 27 Pa. In this case, the average voltage amplitude measured in the experiments and used in the simulations was 54 V.

In Figs. 4(a) and 4(b) we present some selected emission patterns observed in the experiments and obtained from the simulations with different number densities of the microparticles. As it can be seen from Figs. 4(a) and 4(b), the model employed in the present work is able to reproduce, at least qualitatively, the experimental observations: the increase in the microparticle number density leads to a more uniform spatial distribution of the emission intensity. This observation agrees with the findings of Ref. [19] and is known to be caused by the growth of the electric field oscillation amplitude in the plasma bulk. The latter effect is connected with the decrease in plasma conductivity, which is a consequence of the electron depletion by the microparticles. The same phenomenon was previously observed in electronegative discharges [20–22], where the negative ions immobilize the negative charge in a similar way as the microparticles do it in complex plasmas.

The above discussion can be supported by considering the charge density distributions for different plasma components. The corresponding numerical results for the selected emission patterns are shown in Fig. 4(c). As it can be seen, the emission pattern becomes more uniform as the microparticle charge density in the bulk region increases and the electron charge density decreases. On the other hand, as it follows from Fig. 4(c), the ion charge density in the sheath regions does not change significantly. Therefore, the displacement current induced in the oscillating rf sheath remains virtually constant with increasing microparticle number density. As a result, the total current in the system is not strongly affected by the microparticles. This fact, in combination with the reduction of plasma conductivity due to the electron depletion, explains the increase in the electric field oscillation amplitude and respective growth of the emission intensity in the bulk.

The distributions of the microparticle charge density presented in Fig. 4(c) are consistent with those observed in previous works devoted to the numerical studies of the microparticle arrangement [30–33,48,49]. In addition, we show in Fig. 4(c) the boundaries of the regions occupied by the microparticles in the experimental images near the discharge central axis. The comparison with the experimental data shows that our model reproduces well the positions of the microparticle cloud boundaries. The main disagreement with the experimental observations is connected with the existence of the Havnes parameter [34] (i.e., the ratio $n_{eip}/n_{ei}$) for our problem is mainly governed by the changes in the microparticle number density. The maximum value of the Havnes parameter obtained in our simulations was of the order of 2.5.

**B. Variation of the microparticle amount**

In the simulations, the initial level of the microparticle number density [plateau of the blue line in Fig. 3(a)] was varied in the range between $10^{11}$ and $5 \times 10^{11}$ m$^{-3}$. In the experiments, the microparticle number density was successively increased by additional injection of microparticles. The experimental measurements showed that the gas pressure variations do not affect qualitative evolution of the emission pattern with increasing number of microparticles. For this reason, we focus below on the results obtained at the gas pressure of 27 Pa. In this case, the average voltage amplitude measured in the experiments and used in the simulations was 54 V.

In Figs. 4(a) and 4(b) we present some selected emission patterns observed in the experiments and obtained from the simulations with different number densities of the microparticles. As it can be seen from Figs. 4(a) and 4(b), the model employed in the present work is able to reproduce, at least qualitatively, the experimental observations: the increase in the microparticle number density leads to a more uniform spatial distribution of the emission intensity. This observation agrees with the findings of Ref. [19] and is known to be caused by the growth of the electric field oscillation amplitude in the plasma bulk. The latter effect is connected with the decrease in plasma conductivity, which is a consequence of the electron depletion by the microparticles. The same phenomenon was previously observed in electronegative discharges [20–22], where the negative ions immobilize the negative charge in a similar way as the microparticles do it in complex plasmas.

The above discussion can be supported by considering the charge density distributions for different plasma components. The corresponding numerical results for the selected emission patterns are shown in Fig. 4(c). As it can be seen, the emission pattern becomes more uniform as the microparticle charge density in the bulk region increases and the electron charge density decreases. On the other hand, as it follows from Fig. 4(c), the ion charge density in the sheath regions does not change significantly. Therefore, the displacement current induced in the oscillating rf sheath remains virtually constant with increasing microparticle number density. As a result, the total current in the system is not strongly affected by the microparticles. This fact, in combination with the reduction of plasma conductivity due to the electron depletion, explains the increase in the electric field oscillation amplitude and respective growth of the emission intensity in the bulk.

The distributions of the microparticle charge density presented in Fig. 4(c) are consistent with those observed in previous works devoted to the numerical studies of the microparticle arrangement [30–33,48,49]. In addition, we show in Fig. 4(c) the boundaries of the regions occupied by the microparticles in the experimental images near the discharge central axis. The comparison with the experimental data shows that our model reproduces well the positions of the microparticle cloud boundaries. The main disagreement with the experimental observations is connected with the existence of the Havnes parameter [34] (i.e., the ratio $n_{eip}/n_{ei}$) for our problem is mainly governed by the changes in the microparticle number density. The maximum value of the Havnes parameter obtained in our simulations was of the order of 2.5.
FIG. 4. Spatiotemporal emission patterns of an rf discharge in argon at 27 Pa and 54 V rf amplitude with increasing (from left to right) microparticle number density: (a) experiment and (b) simulations. The leftmost figures correspond to the case of pure plasma. The emission intensity is given in arbitrary units. (c) The rf-period-averaged charge density distributions for the electrons (red line), microparticles (green line) and ions (blue line) obtained from the simulations. The results correspond to the emission patterns shown in Fig. 4(b). The dashed lines show the boundaries of the microparticle cloud and the dotted lines show the axial void extension observed in the experiments [see Fig. 1(b)].

of the central void. While the void is visible in all experimental images, it is not present in the microparticle number density distributions obtained from the one-dimensional simulations.

C. Plasma emission inside the void

To elucidate the possible effect of the void on the emission pattern we performed an additional simulation run with a fixed microparticle number density distribution which mimics that observed in the experiments [blue line in Fig. 3(a)]. Equation (4) was not considered in this case.

The obtained results are summarized in Fig. 5. As it can be seen, the emission pattern changes drastically with respect to those in Fig. 4(b). The emission coming from the void noticeably dominates over the emission coming from the other parts of the discharge. This contradicts the experimental observations, where no visible effect of the void on the emission pattern is detected [see Fig. 4(a)].

On the other hand, the emission pattern presented in Fig. 5(a) correlates with the calculated distribution of the electron number density in this region [see Fig. 5(b)]. The latter is simply a consequence of plasma quasineutrality and results from the abrupt reduction of the microparticle number density.

D. Effect of the void position

In addition, a row of experiments was conducted in an attempt to find the dependence of the emission pattern on the position of the void inside the microparticle cloud. The experiments were performed at the gas pressure of 36 Pa and the voltage amplitude of 53 V. The position of the void was varied by changing the temperature difference between the electrodes. Representative examples of the observed emission patterns are shown in Fig. 6. As it can be seen, the variation of the void position does not produce any significant effect on the emission pattern.

V. DISCUSSION

The results presented in Sec. IV give rise to the following questions:
FIG. 5. The results of the simulation run performed for a fixed microparticle number density distribution with the void in the central region [blue line in Fig. 3(a)]. The discharge parameters are the same as in Fig. 4. (a) Spatiotemporal emission pattern. The emission intensity is given in arbitrary units. (b) The rf-period-averaged charge density distributions for the electrons (red line), microparticles (green line), and ions (blue line). The dashed lines show the boundaries of the microparticle cloud and the dotted lines show the void extension defined in the simulation [see Fig. 3(a)].

(i) Why is the void formation not reproduced by the numerical model?
(ii) Why is the presence of the void not reflected in the experimentally observed spatiotemporal emission pattern?

A. Void closure

In order to discuss the first question, we analyze the behavior of the total force acting on a microparticle in the discharge. In Fig. 7, we show the distributions of this force obtained from two different simulation runs. In the first run, the microparticle number density distribution [blue line in Fig. 3(a)] was fixed. In the second run, the same initial distribution was allowed to evolve self-consistently. The resulting microparticle number density distribution is given by the red line in Fig. 3(a).

As it can be seen from Fig. 7, the total force on a microparticle exhibits a sharp peak in the vicinity of the void boundary. The electric field responsible for this peak appears as a consequence of the double-layer formation at the boundary between the plasmas with different electron thermal fluxes (see, e.g., Ref. [50]). This effect may be enhanced by the presence of the rf electric field perpendicular to the boundary [51]. However, it is difficult to separate the two mechanisms in the frame of a one-dimensional model.

The discussion above indicates that the void closure seems to be an inevitable phenomenon for the considered one-dimensional problem. In fact, as long as the void exists, the double layer electric field at the void boundary will push the microparticles into the central region of the discharge. The microparticles can reach the equilibrium position near the void edge only if the electrostatic force exerted on a microparticle at the void boundary will be comparable to the ion drag force. This condition can be satisfied only when the effect of microparticles on the plasma is very small.

In addition, it should be noted that the mechanism of the void closure described above differs from that proposed in Ref. [15] to explain the heartbeat instability observed under certain conditions. The double layer in our case occurs as a consequence of the contact between two plasmas with different electron thermal fluxes. This phenomenon does not have a critical character: The double layer forms even if the plasmas in contact are only slightly different (i.e., if the microparticle number density is very small). In contrast to that, collapse of the void during the heartbeat instability is a critical phenomenon [15] which occurs due to an abrupt change in the
double layer structure caused by steadily increasing plasma absorption at the void boundary.

As it can be also seen in Fig. 7, the total force on a microparticle calculated within the self-consistent model is nearly zero inside the microparticle cloud and does not reveal any noticeable potential barriers for the microparticles in the central region of the discharge. It is worth noting that the same finding has been already reported in Ref. [49].

B. Emission pattern

Let us now discuss the second question stated at the beginning of this section. The results shown in Fig. 5 demonstrate that the existence of the fixed void within the considered one-dimensional model would provide a dramatic effect on the emission pattern. A possible reason why it is not observed in the experimental data is the line-of-sight averaging (see Sec. II C). However, a simple estimation shows that although the line-of-sight averaging significantly affects the intensities seen by the ICCD camera, it will not be able to obscure a feature shown in Fig. 5. Under typical conditions, the maximal radial width of the void is approximately 30% of the plasma diameter. If we assume an emission pattern predicted by Fig. 5, the void would be approximately factor of 2 more luminous than its surroundings, and in the line-of-sight-integrated picture, its intensity (in the middle) will be 30% larger than in the regions occupied by the microparticles. Therefore, emission peak associated with the void would be detected in the ICCD images as well as in the spatiotemporal patterns. We would like to stress that the emission intensity peak inside the void has previously been detected under certain conditions by a simple line-of-sight integrated measurements in different experimental setups [1–3,52,53], including ours [15].

This suggests that under the conditions of the present work, a real three-dimensional void produces a much weaker disturbance of the spatiotemporal emission pattern than that shown in Fig. 5.

C. Two-dimensional effects

Our findings suggest that the two-dimensional effects might be crucial in understanding the discrepancies between the experimental and simulation results observed in the present study. One important feature, which is not considered in the one-dimensional model (but is present in the experiment), is the radial diffusion of the plasma. The radial diffusion serving as an additional mechanism of void plasma losses could lead to the reduction of the electron number density inside the void. This would, in turn, lead to the reduction of the double layer electric field at the void boundary. Thus, it seems possible that under certain conditions the electrostatic force pushing the microparticles towards the void center could be compensated by the drag force exerted by outflowing ions. The reduction of the electron number density in the void could, in its turn, lead to the reduction of the influence of the void on the rf-period-resolved emission pattern to such extent, that the void plasma emission could be obscured by the line-of-sight averaging.

D. Void boundary

Another important issue is the description of the void boundary. As pointed out in Ref. [54], the models, where the microparticle component is treated as a fluid, are not able to provide adequate description of microparticle structures of the order of several inter-particle distances. In particular, the fluid models of microparticle component mostly fail to reproduce the sharp void boundary as well as the microparticle compression near the void edge. Therefore, more accurate theoretical description of the microparticle structures at the void boundary might play an important role in explaining the findings of the present work.

VI. CONCLUSIONS

In conclusion, the effect of micron-sized particles on a capacitively coupled rf discharge has been studied both experimentally and via numerical simulations. In the experiments, microparticle clouds were confined in an argon discharge with the help of thermophoretic levitation. The space- and time-resolved emission measurements were performed with different amounts of microparticles. The corresponding numerical simulations were carried out on the basis of a one-dimensional discharge model describing the plasma and microparticle components in a self-consistent way.

The main findings of our work can be summarized as follows. The spatiotemporal emission patterns observed in the experiments are qualitatively well reproduced by the self-consistent numerical simulations. However, there is a strong disagreement between the experimental and numerical results regarding the formation of the central void (microparticle-free region) and the influence of the void on the emission profile. In particular, the void formation is not reproduced by the self-consistent simulations. Moreover, it is shown that the void closure seems to be an inevitable effect in the framework of the considered model. In addition, the simulations with a fixed microparticle arrangement, which mimics the presence of the void, indicate that the void induced emission would noticeably affect the observed emission pattern. This, however, contradicts the experimental data.

The observed discrepancies between experimental and numerical results can be attributed either to the two-dimensional effects (e.g., radial plasma diffusion), which are not taken into account by our model, or to the incorrect description of the sharp void boundary by a fluid model of the microparticle component. These hypotheses can be verified by more detailed numerical simulations and active depth-resolved optical plasma diagnostics, e.g., laser-induced fluorescence.

ACKNOWLEDGMENT

The authors appreciate helpful discussions with A. Zobnin.

APPENDIX: CODE VALIDATION

The numerical code used in the present work was validated against the known benchmarks and experimental data both for the pure discharge and discharge with microparticles. The validation of the code for the case of the pure discharge was
described in details in Ref. [28]. In particular, the code was tested to reproduce the experimental data of Refs. [55,56] for the argon discharge and the recently published benchmark of Ref. [57] for the helium discharge.

For the case of the argon discharge with microparticles, the code was validated against the experimental data of Ref. [58]. Namely, we have simulated the steady-state distributions of the microparticle number density in the argon discharge ($L = 3 \text{ cm}$) at the gas pressure of 24 Pa and different voltage amplitudes. The microparticle number density distributions for two selected voltage amplitudes (30 V and 60 V) are shown in Fig. 8. As it can be seen in Fig. 8, our simulations reproduce the formation of the central void at the voltage amplitude of 60 V and predict the closure of the void at the voltage amplitude of 30 V. These results are in agreement with the theoretical estimates and experimental observations of Ref. [58]. Moreover, our results agree also with the results of corresponding simulations presented in Ref. [32].

It should be emphasized that the experiments of Ref. [58] represent the situation when the effect of microparticles on the discharge properties is sufficiently small to be negligible. In contrast our work deals with the case of strong mutual interaction between microparticles and discharge plasma. Therefore the effects discussed in the present paper differ qualitatively from those studied in Ref. [58].